



## MAIL STOP PGPUB DRAWINGS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Agent's Docket No. 12110-US

In re Application of ) Allowed: **November 13, 2003**  
 )  
 **OUELLET, Luc et al.** ) Confirmation No.: **2645**  
 )  
 Serial No: **09/956,916** ) Art Unit: **1762**  
 )  
 Filed: **September 21, 2001** ) Examiner: **MEEKS, Timothy Howard**  
 )

For: **METHOD OF DEPOSITING AN OPTICAL QUALITY SILICA FILM BY PECVD**

February 3, 2004

**Commissioner for Patents  
U.S. Patent and Trademark Office  
Alexandria. VA 22313-1450**

### **TRANSMITTAL LETTER**

Sir:

Submitted herewith are the following documents:

- Letter to the OFFICIAL DRAFTSPERSON
- Transmittal of Formal Drawings Form
- Formal Drawings (37 sheets, Figures 1 to 18)

Respectfully submitted,

BY: Richard J. Mitchell

Richard J. Mitchell  
Reg. No. 34,519  
Agent of Record

MARKS & CLERK  
P. O. Box 957, Station B  
Ottawa, Ontario Canada K1P 5S7 (613) 236-9561



## **MAIL STOP PGPUB DRAWINGS**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Agent's Docket No. 12110-US**

In re Application of	)	Allowed: November 13, 2003
	)	
<b>OUELLET, Luc et al.</b>	)	Confirmation No.: 2645
	)	
Serial No: 09/956,916	)	Art Unit: 1762
	)	
Filed: September 21, 2001	)	Examiner: MEEKS, Timothy Howard
	)	

For: **METHOD OF DEPOSITING AN OPTICAL QUALITY SILICA FILM BY PECVD**

February 3, 2004

**Commissioner for Patents  
U.S. Patent and Trademark Office  
Alexandria, VA 22313-1450**

### **LETTER TO THE OFFICIAL DRAFTSPERSON**

Sir:

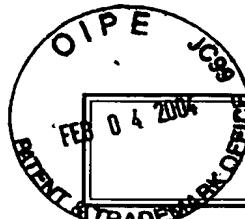
The Official Draftsperson is respectfully requested to substitute the attached formal drawings for the informal drawings on file.

Respectfully submitted,

BY: 

Richard J. Mitchell  
Reg. No. 34,519  
Agent of Record

**MARKS & CLERK  
P. O. Box 957, Station B  
Ottawa, Ontario Canada K1P 5S7 (613) 236-9561**

**TRANSMITTAL OF FORMAL DRAWINGS**

(In Response to Notice of Informal Drawings)

Docket No.

12110-US

In Re Application Of:

Luc OUELLET, et al.

Serial No. 09/956,916	Filing Date September 21, 2001	Batch No. 2645	Examiner MEEKS, Timothy Howard	Art Unit 1762
--------------------------	-----------------------------------	-------------------	-----------------------------------	------------------

Invention:

**METHOD OF DEPOSITING AN OPTICAL QUALITY SILICA FILM BY PECVD**

Address to:  
**Assistant Commissioner for Patents**  
Washington, D.C. 20231

Transmitted herewith are:

37 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

  
SignatureDated: February 3, 2004

Richard J. Mitchell

34,519

Marks & Clerk Canada  
P.O. Box 957  
Station B  
Ottawa, ON, K1P 5S7  
Phone: (613) 236-9561



\* 2 3 5 5 3 \*

I certify that this document and attached drawings are being deposited on February 3, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

*Signature of Person Mailing Correspondence**Typed or Printed Name of Person Mailing Correspondence*